## Session Program

**6–10 Sept 2010**

# Pixel2010 - International Workshop on Semiconductor Pixel Detectors for Particles and Imaging

## *Pixel Technologies III*

Grindelwald, Switzerland

# Thursday 9 September

14:00

## Pixel Technologies III

**Session** | **Location:** Grindelwald, Switzerland | **Convener:** H.-G. Moser

14:00–14:20 **SOI pixel detector with micro-bump bonding**

**Speaker**
M. Motoyoshi

14:20–14:40 **Progress on 3D Integration Devices at Fermilab**

**Speaker**
R. Yarema

14:40–15:00 **Metal and Hybrid TimePix Detectors Imaging Beams of Particles**

**Speaker**
V. Pugatch

15:00–15:30 **CiS - Your partner from development to production of silicon sensors**

**Speaker**
R. Roeder

15:30